

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE	ATTY. DOCKET NO. NSL-025	SERIAL NO. 10/782,545
LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)	APPLICANT Martin R. Roscheisen et al.	
	FILING DATE February 19, 2005	GROUP 1762

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

LISA	A	US Patent Application 10/782,163 to Brian M. Sager filed February 19, 2005 entitled "Device based on coated nanoporous structure" (NSL-024)
HEB	B	US Patent Application 10/782,233 to Karl Pichler filed February 19, 2005 entitled "Roll-to-roll atomic layer deposition method and system" (NSL-026)
LISA	C	US Patent Application 10/782,017 to Dong Yu et al. filed February 19, 2005 entitled "Solution-based fabrication of photovoltaic cell" (NSL-029)

EXAMINER <i>[Signature]</i>	DATE CONSIDERED 4/24/06
* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	